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PATENT
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Johannes Kaeppeler, *et al.*
Serial No. 10/685,233	Filing Date: October 14, 2003
Title of Application:	Method For Depositing Especially Crystalline Layers From The Gas Phase Onto Especially Crystalline Substrates
Confirmation No. 4633	Art Unit: 1762
Examiner	

Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

Supplemental Information Disclosure Statement by Applicants

As a means of complying with the duty of disclosure set forth in 37 CFR §1.56, Applicants list the following references (a copy of listed patent is enclosed).

U.S. Patent Documents				
Exam. Initials	Class/ Subclass.	Document No.	Date	Name
	118/730	5,702532	12/1997	Wen et al.

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May 12, 2004

Gregory D. Venuto

The listed patent pertain in a general way to the subject matter of the application, but are not necessarily considered to be analogous prior art.

Respectfully submitted,

May 12, 2004

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Date Considered

Examiner